

U.S. Department of Commerce, Patent and Trademark Office					Attorney Docket No.		Serial No.	
					DC-03112		10/688,237	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant(s)			
(Use several sheets if necessary)					Munif Farhan Halloush, et al.			
					Filing Date		Group	
					October 18, 2003		2655	
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
/TG/	AA	2003/0021201 A1	Jan. 30, 2003	Kobayashi	369	47.39		
/TG/	AB	2003/0058765 A1	Mar. 27, 2003	Schreurs et al.	369	47.53		
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
/TG/	AL	KR2003069706	Aug. 27, 2003	Republic of Korea	G11B	7/004	<input type="checkbox"/>	<input type="checkbox"/>
/TG/	AM	KR2002096641	Dec. 31, 2002	Republic of Korea	G11B7	7/125	<input type="checkbox"/>	<input type="checkbox"/>
	AN						<input type="checkbox"/>	<input type="checkbox"/>
	AO							
	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
/TG/	AR	Ohkubo, S. et al. "Optimization of Write Strategy in a PRML System for High Density Recording" International Symposium on Optical Memory and Optical Data Storage Topical Meeting, July 7-11, 2002, Pages 425-427						
	AS							
	AT							
Examiner		/Tawfik Goma/		Date Considered		04/27/2007		
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								